

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/628,466	YEN, CHI-YU
Examiner	Art Unit	
Michael A. Friedhofer	2832	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
200	5r,5a	3/3/2005	MAF
200	512-514	3/3/2005	MAF
200	517,341	3/3/2005	MAF
200/344,345		3/3/2005	MAF